



Image

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki HASHIMOTO

Application No.: 09/486,556

Group Art Unit: 2827

Filed: February 29, 2000

Docket No.: 105029

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURE
THEREOF, CIRCUIT BOARD AND ELECTRONIC INSTRUMENT

NOTICE OF EXPRESS ABANDONMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Applicants hereby expressly abandon this application.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Thomas J. Pardini
Registration No. 30,411

JAO:TJP/sqb

Date: November 7, 2003

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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